

Electronic Acknowledgement Receipt

EFS ID:	1429674
Application Number:	10792323
International Application Number:	
Confirmation Number:	4370
Title of Invention:	Apparatus and method for vaporizing solid precursor for CVD or atomic layer deposition
First Named Inventor/Applicant Name:	Lawrence C. Lei
Customer Number:	44257
Filer:	Keith M. Tackett/Tammi Thomas
Filer Authorized By:	Keith M. Tackett
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1	Request for Continued Examination (RCE)	005191C1Y2_RCE_EF.pdf	73087	no	1

Warnings:

This is not a USPTO supplied RCE SB30 form.

Information:	
Total Files Size (in bytes):	73087
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